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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/607,141	06/26/2003	Michael J. Lombardi	TAZ-232 5154		
37694 7	7590 07/15/2005		EXAM	EXAMINER	
WOOD, HERRON & EVANS, LLP (TOKYO ELECTRON)			LUND, JEFFR	LUND, JEFFRIE ROBERT	
2700 CAREW	TOWER			·	
441 VINE STREET			ART UNIT	PAPER NUMBER	
CINCINNATI, OH 45202			1763		

DATE MAILED: 07/15/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

Supplemental Notice of Allowability

Application No.	Applicant(s)		
10/607,141	LOMBARDI ET AL.		
Examiner	Art Unit		
Jeffrie R. Lund	1763	•	

	Jeffrie R. Lund	1763	
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS (herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGOR of the Office or upon petition by the applicant. See 37 CFR 1.313	OR REMAINS) CLOSED in this apport or other appropriate communication GHTS. This application is subject to	olication. If not include will be mailed in due	ed course. THIS
1. This communication is responsive to <i>Interview of 7/11/05</i> .			
2. The allowed claim(s) is/are <u>1-16</u> .			
3. \boxtimes The drawings filed on <u>26 June 2003</u> are accepted by the Ex	caminer.		
 4. Acknowledgment is made of a claim for foreign priority un a) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONM	been received. been received in Application No cuments have been received in this in	national stage applica	
 THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftsperse. 1) hereto or 2) to Paper No./Mail Date 	s reason(s) why the oath or declarate be submitted.	tion is deficient.	OTICE OF
(b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the standard of the control of the standard of the control of	84(c)) should be written on the drawing to 37 CFR 1.121(c) sit of BIOLOGICAL MATERIAL n	ngs in the front (not the d). nust be submitted. N	
 Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	5. Notice of Informal P 6. Interview Summary Paper No./Mail Dat 7. Examiner's Amenda 8. Examiner's Stateme 9. Other	(PTO-413), e nent/Comment	,

U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04)

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Joseph Jordan on July 11, 2005.

The application has been amended as follows:

Claim 10 has been amended to correct a typographical error in the Examiner's Amendment mailed June 17, 2005. Claim 10 has been amended to read:

10. (Currently amended) The method of claim 1 further comprising:

providing each of at least two of the chambers with a gas flow conductance path to the exhaust volume;

providing each of said at least two of the chambers with a replaceable protective shield set configured to substantially protect walls of the chamber and the gas flow conductance path from deposition from the chamber, and to partially impede the gas flow from the respective chamber through the respective gas flow conductance path to the exhaust volume; and

providing a controller programmed to control the processing of wafers in the chambers by controlling the supply of process gas into each of said two of the the chambers such that gas flows from the chamber, through the respective path and to the exhaust volume, and such that each chamber is maintained at a different controlled

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processing pressure that is higher than the pressure at the exhaust volume.

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Jeffrie R. Lund whose telephone number is (571) 272-1437. The examiner can normally be reached on Monday-Thursday (6:30 am-6:00pm).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on (571) 272-1435. The fax phone number for the organization where this application or proceeding is assigned is (571) 273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Jeffrie R. Lund Primary Examiner Art Unit 1763

JRL 7/12/05